



I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: December 14, 2005 Signature: _____

(Raymond Garguilo, Jr.)

Docket No.: TESSERA 3.0-320
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kang et al.

Application No.: 10/655,952

Group Art Unit: 2815

Filed: September 5, 2003

Examiner: S. B. Geyer

For: ASSEMBLIES HAVING STACKED
SEMICONDUCTOR CHIPS AND METHODS
OF MAKING SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT AND
REQUEST FOR CONSIDERATION OF INFORMATION UNDER 37 CFR § 1.97 (C)

Dear Sir:

It is respectfully requested that the references listed on the enclosed form be made of record and considered with respect to the above-referenced U.S. patent application. A copy of each non-U.S. reference is enclosed. Submission of the present Information Disclosure Statement should not be taken as an admission that the cited references are legally available prior art or that the same are pertinent or material.

It is respectfully requested that the references cited in the enclosed form be considered pursuant to 37 C.F.R. § 1.97(c). Please charge deposit account No. 12-1095 in the amount of \$180.00 pursuant to 37 C.F.R. § 1.17(p).

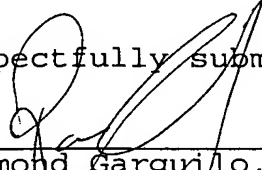
Application No.: 10/655,952

Docket No.: TESSERA 3.0-320

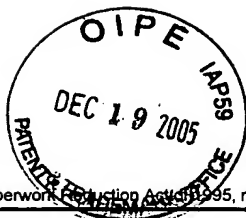
In the event that any additional fee is due in connection with the present request, the same should be charged to our deposit account No. 12-1095.

Dated: December 14, 2005

Respectfully submitted,

By 
Raymond Garguilo, Jr.
Registration No.: 50,930
LERNER, DAVID, LITTENBERG,
KRUMHOLZ & MENTLIK, LLP
600 South Avenue West
Westfield, New Jersey 07090
(908) 654-5000
Attorney for Applicant

LD-453\



PTO/SB/08a/b (07-05)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Project of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/655,952-Conf. #8891
				Filing Date	September 5, 2003
				First Named Inventor	Teck-Gyu Kang
				Art Unit	2815
				Examiner Name	S. B. Geyer
Sheet	1	of	1	Attorney Docket Number	TESSERA 3.0-320

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA	US-07/552,578	07-13-1990	FORTHUN	
	AB*	US-2001/0006252-A1	07-05-2001	KIM ET AL.	
	AC*	US-5,008,496	04/1991	Schmidt et al.	
	AD*	US-5,054,756	04-25-2000	DISTEFANO ET AL.	
	AE*	US-5,121,676	09-19-2000	SOLBERG	
	AF*	US-5,956,234	09-21-1999	MUELLER	
	AG*	US-6,172,418	01/2001	Iwase, Kanji	
	AH*	US-6,208,521	03/2001	Nakatsuka, Yasuo	
	AI*	US-6,239,384	05-29-2001	SMITH ET AL.	
	AJ*	US-6,469,377	10/2002	Kondo, Yoichiro	
	AK*	US-6,469,903	10/2002	Kondo, Yoichiro	
	AL*	US-6,646,335	11/2003	Emoto	
	AM*	US-6,677,670	01/2004	Kondo, Yoichiro	

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	BA	JP-62-226307	03-16-1989	HITACHI LTD.	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * CITE NO.: Those application(s) which are marked with an single asterisk (*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature		Date Considered	
--------------------	--	-----------------	--